

12-19-03

PATENT

#5 SP 2185

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date

Ayesha J. Shaikh

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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DEC 18 2003

Applicants : Trung T. Doan and
Dean A. Klein

Attorney Docket No.: 500966.01
Technology Center 2100

Serial No. : 09/994,516

Group Art Unit : 2185

Filed : November 26, 2001

Examiner : Not Yet Assigned

Title : CHINE STATE STORAGE APPARATUS AND METHOD

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449 (copies of the cited references, as required under 37 C.F.R. § 1.98, are enclosed). Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

Applicants also wish to make known to the Patent and Trademark Office that an application, Serial No. 10/690,810, describing and claiming subject matter that is similar to the subject matter of this application, was filed on October 20, 2003. This related application, as well as any prior art cited therein, may be material to the examination of this application. A copy of this related application as filed is submitted herewith in accordance with 37 C.F.R. § 1.98(d).

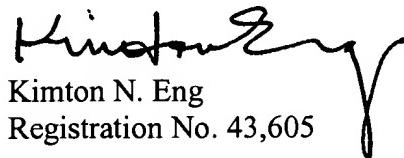
Applicants also wish to make known to the Patent and Trademark Office that an application, Serial No. 10/695,383, describing and claiming subject matter that is similar to the subject matter of this application, was filed on October 27, 2003. This related application, as well as any prior art cited therein, may be material to the examination of this application. A copy of this related application as filed is submitted herewith in accordance with 37 C.F.R. § 1.98(d).

I hereby certify that no item set forth on the attached form PTO-1449 was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge, after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Supplemental Information Disclosure Statement.

Please acknowledge receipt of this Supplemental Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,

DORSEY & WHITNEY LLP


Kimton N. Eng
Registration No. 43,605

KNE:ajs

Enclosures:

- Postcard
- Form PTO-1449
- Cited References (3)
- Copies of Related Applications (2)

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